

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
 )  
Shunpei Yamazaki et al. )  
 )  
Serial No.: 09/724,002 )  
 )  
Filed: November 28, 2000 )  
 )  
For: Film Deposition Apparatus And )  
Method Of Manufacturing A Light )  
Emitting Device Using The )  
Apparatus )  
 )  
Art Unit: 1792 )  
 )  
Confirmation No.: 7243 )  
 )  
Examiner: Karla A. Moore )

Commissioner for Patents  
P.O. Box 1450  
Alexandra, VA 22313-1450

**AMENDMENT M**

Applicants have the following response to the Office Action of February 13, 2009.

Please amend in the above-identified application as follows: